Micro-Structured Electrode Arrays: Characterization of High Frequency Discharges at Atmospheric Pressure

**Introduction**

Non-thermal plasma processing techniques optimized for atmospheric pressure applications have been the subject of recent, growing interest due to their significant industrial advantages. At atmospheric pressure, thin film deposition is possible with very high rates and cost-intensive vacuum technology can be avoided. There have been many approaches published recently to overcome problems in generating and sustaining a stable uniform non-thermal atmospheric plasma.\(^{[1-11]}\)

Recently, micro-structured electrode (MSE) arrays have been introduced as alternative atmospheric pressure plasma sources.\(^{[12-15]}\) They consist of a system of planar and parallel electrodes (comb structure, see Figure 1) arranged on an insulating substrate and are manufactured by means of modern micro machining and galvanic techniques. The electrode dimensions, especially the electrode gap width, \(d\), in the \(\mu\)m-range, are small enough to generate sufficiently high electric field strengths to ignite gas discharges by applying only moderate radio frequency (RF, 13.56 MHz) voltages (less than 400 V).

**Summary:** Micro-structured electrode (MSE) arrays allow large area uniform glow discharges to be generated over a wide pressure range up to atmospheric pressure. Electrode widths, thicknesses and distances in the \(\mu\)m-range are realized by means of modern micro machining and galvanic techniques. These electrode dimensions are small enough to generate sufficiently high electric field strengths to ignite gas discharges by applying only moderate radio frequency (RF, 13.56 MHz) voltages (80 V to 390 V in Ne, H\(_2\), Ar, N\(_2\) and air). The non-thermal plasma system can be characterized by a special probe measuring the electric parameters. MSE driven plasmas demonstrate different behavior from conventional RF or DC discharge plasmas. Due to the very small electrode gap width, \(d\), the behavior of the charged particles in the RF field of our system could be described with the DC Townsend breakdown theory. Partially, dependent on the pressure range and type of gas, the breakdown mechanism was dominated by field electron emission or by a high frequency regime. The voltage-current characteristic and electron density of the MSE plasma in H\(_2\) at atmospheric pressure were characteristic for a glow discharge. Using MSE arrays as plasma sources, several applications have been developed and successfully tested including atmospheric pressure plasma chemistry (decomposition of waste gases like CF\(_4\) and NO) and the sterilization of food packaging materials at atmospheric pressure.

**Keywords:** atmospheric pressure glow discharges (APGD); micro-structured electrode; Paschen curves; radio frequency glow discharges (RFGD); sterilization

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In the following sections, the breakdown mechanism of the MSE driven radio frequency discharges for two different electrode gap widths (70 \(\mu\)m and 25 \(\mu\)m) are characterized and their special behavior demonstrated, which can be seen to differ from conventional discharges. A voltage-current characteristic in He at atmospheric pressure has been determined and the electron density estimated, in order to classify the MSE plasma as a glow discharge. Additionally, successful applications of the MSE arrays are briefly summarized.

**Experimental Part**

The MSE arrays have been studied as a non-thermal radio frequency (13.56 MHz) plasma source with the experimental setup shown schematically in Figure 1. The gas inlet system and vacuum system have been described in detail elsewhere.\(^{[14]}\) A gas flow rate of 200 sccm was set up by means of mass flow controllers. The discharges were generated using an RF power supply (ENI ACG-3B) equipped with a matching network (ENI MW-5D). The RF generator was power controlled from 0 W to 300 W with steps of 1 W. The generator power, \(P_{\text{gen}}\), used to ignite the plasma ranged between 3 W (Ne) and 45 W (N\(_2\)). Between the matching network and the MSE array, a special probe (ENI VI-Probe) was inserted in order to measure voltage \(U\), current \(I\), phase angle \(\phi\) and the effective power, \(P_{\text{eff}}\), of the system. The effective powers inserted into the plasma were dependent on the gas chosen and generator power, but were independent of pressure (in the range 10 to 100 kPa).

The MSE arrays were micro-machined nickel structures on a 500 \(\mu\)m thick alumina substrate. The electrode gap design is shown in Figure 2. In order to achieve plasma operation at high-pressure ranges, an electrode thickness up to 100 \(\mu\)m was necessary. Therefore, for 70 \(\mu\)m structures, a 150 \(\mu\)m thick layer of SU8 photo resin was spun on a ceramic wafer already covered with a thin copper layer.\(^{[16]}\) The SU8 was prebaked by heating at 373 K. UV-exposure with a chrome mask initiated crosslinking which was then continued on a hotplate. The non-polymerized resin was resolved, leaving a complementary geometry to the desired electrode design. The production of 25 \(\mu\)m MSE arrays was more complicated, because the SU8 mold needed to be stabilized to obtain sufficient quality of the electrode gap structures. Therefore, anchoring structures were integrated into the electrodes. With this design, a thickness of 35 \(\mu\)m could be realized. The electrode width of 1 350 \(\mu\)m and electrode length of 7 200 \(\mu\)m were identical for both structures.

After plating with nickel, most of the SU8 was removed by a long exposure to acetone, and the remaining resin was etched.
away by exposure to a CF₄/O₂ plasma. The start layer was etched away with Alketch I+II (Candor Chemie, Bochum, Germany). After cleaning, a 400 nm alumina layer was deposited on the structures to form a protective barrier.

Characterization of the MSE Plasma

The electrode gap had a complex geometry with incorporated protrusions (see Figure 2) allowing the generation of large-area uniform glow discharges in He and Ne at pressures up to 150 kPa and in Ar and N₂ up to 120 kPa.[¹⁵] With the 25 µm structures, glow discharges could be generated even in air up to 50 kPa. In order to achieve higher pressures in air, very high applied generator powers (>45W) were necessary to ignite the plasma. Under these conditions, the MSE arrays started to age with the increasing occurrence of sparks over time, finally resulting in destruction by arcing. Non-thermal discharges were generated at the five gaps between the electrodes and, up to 40 kPa, the plasma covered the whole electrode system.[¹⁴,¹⁵] Using the gases Ne, He and Ar, the plasma burned in all electrode gaps, but with N₂ at a pressure higher than 60 kPa the discharge burned only in one electrode gap. In order to ignite the plasma, an applied generator power of about 3 W in Ne, 5 W in He, a range from 9 W to 22 W in Ar and a range from 18 W to 45 W in N₂ was necessary, depending on the pressure.

In Figure 3 the breakdown voltages (ignition potentials \( U_{Ip} \)) of the gases Ne, He, Ar and N₂ for an electrode gap width, \( d \), of 70 µm and in the pressure range 10 to 100 kPa are shown.

In order to describe the behavior of the charged particles in the RF field of this system, the DC Townsend breakdown theory was used due to the very small electrode gap width. The motion of the charged particles is drift controlled analogous to DC discharges, because the oscillatory amplitudes of the electrons as well as the ions exceed \( d/2 \) (35 µm) with the exception of Ne and Ar at pressures higher than 80 kPa (see Figure 4).[¹⁷] The ion oscillation amplitudes \( z_0 \) in Figure 4 were calculated using Equation (1):

\[
   z_0 = \frac{e \cdot E_0}{m \cdot \omega \cdot \sqrt{\omega^2 + v_c^2}}
\]

where \( E_0 \) is the electric field amplitude, \( m \) is the mass of the charged particle, \( \omega \) is the angular frequency (\( 2\pi \times 13.56 \text{ MHz} \)) and \( v_c \) is the e⁻-neutral collision frequency. Equation (1) gives the extreme values derived from the solution of the equation of motion (Equation (2)) including the pressure dependent Lorentz collisional term in order to regard friction.[¹⁸]

\[
   m \cdot \frac{d^2 z}{dt^2} + m \cdot v_c \frac{dz}{dt} = e \cdot E_0 \cdot \sin(\omega \cdot t) \tag{2}
\]

The right-hand branches of the Paschen curves of Ar and N₂ and the left-hand branches of Ne and He at pressures higher than 80 kPa obey the Paschen formula derived from the DC Townsend breakdown theory:[¹⁹,²⁰]

\[
   U_{Ip} = \frac{B \cdot (p \cdot d)}{C + \ln(p \cdot d)} \tag{3}
\]

with

\[
   C = \ln \frac{A}{\ln(1/\gamma + 1)} \tag{4}
\]

The mentioned branches were fitted with the Paschen formula (curves shown in Figure 5, fitted constants listed in Table 1). The \( B \) values of the RF field determined for \( d = 70 \) µm are of the same magnitude, but are lower than the \( B \) values of the DC field, because the voltages required to initiate and maintain AC discharges decrease strongly, in comparison to DC glow discharges, with increasing frequency.[¹⁹,²⁰]

The \( B \) value of Ne is much smaller than the DC value, which can partly be explained by the non-matching of the
regions of applicability. At pressures above 80 kPa the ion oscillation amplitudes of Ne do not exceed $d/2$ in the fitted pressure range. Thus, the breakdown controlling regime is a mixture of the high frequency discharge mechanism (also called the $\alpha$ regime) and the Townsend breakdown mechanism, where the high frequency mechanism is dominant.$^{[17,20]}$

For Ar, the fit over the entire range of 10 to 100 kPa yielded an unsatisfactory result, because the dominant breakdown mechanism changes from the DC Townsend mechanism at low pressures to the high frequency mechanism at high pressures. Analogous to Ne, at pressures above 80 kPa, the ion oscillation amplitudes of Ar do not exceed $d/2$. Thus, the fit range is divided in two parts at the limit given by the DC region of applicability. The $B$ values determined confirm this interpretation, the $B$ value at low pressures even corresponding to the DC $B$ value.

In He at high pressures neither breakdown mechanism is dominant. However, the contribution of the DC Townsend breakdown mechanism is more significant than in Ne, because all amplitudes, $z_0$, of He exceed $d/2$. Thus, the RF $B$ value of He is higher in relation to the DC $B$ value than in the case of Ne or Ar. These results were confirmed by RF (13.56 MHz) measurements in He performed by Park et al.$^{[7]}$ Park et al. used a capacitor consisting of two planar square electrodes with an electrode gap width varying from 1 000 $\mu$m to 9 700 $\mu$m. The pressure was varied between 1 kPa and 80 kPa. With electrode distances more than 15 times larger than the MSE gap width (70 $\mu$m), the measured breakdown voltages represented the right hand branch of the He Paschen curve (not shown in Figure 5), and the high frequency regime dominated the breakdown mechanism. The authors likewise calculated the oscillation amplitudes of the charged particles, all of which were lower than $d/2$. Additionally, Park et al. found that variation of the electrode material did not result in a significant deviation of the measured breakdown voltages.$^{[7]}$ With a dominating high frequency regime, processes on the surface of the electrodes represented by the secondary electron emission coefficient $\gamma$ (see below) are negligible. We fitted the data of Park et al. with Equation (3) and obtained a much smaller $B$ value (see Table 1), comparable to the RF $B$ value determined for Ne in relation to the DC $B$ values. In the experiments by Park et al., the He breakdown voltages in the Paschen minimum were lower than 100 V (120 V with $d = 70 \mu$m). The high frequency regime entirely controlled the breakdown mechanism, resulting in a lowering of the breakdown voltage.

While the Paschen curves for He and Ne fit the experimental data very well at high $p \cdot d$ values, they deviate significantly at lower $p \cdot d$ values (see Figure 5). Theoretically, higher breakdown voltages were expected due to the growing lack of impact partners with decreasing $p \cdot d$ values. Hartherz et al. have shown that with $d$ values in the $\mu$m-range, the breakdown voltages are increasingly dominated by field electron emission with decreasing pressure, although the electric field strengths used were less than one magnitude below $10^6$ V $\cdot$ cm$^{-1}$ (q. v. below).$^{[19,21]}$

In Ne and He at pressures lower than 40 kPa, the discharges show a new pressure dependent behavior. As can be

**Table 1.** Fitted constants of the Paschen formula for two different electrode gap widths, $d$, and regions of applicability ($B$ and $E_{\text{eff}}/p$ in V $\cdot$ kPa$^{-1} \cdot$ cm$^{-1}$).

<table>
<thead>
<tr>
<th>$d$</th>
<th>Gas</th>
<th>$B$</th>
<th>$C$</th>
<th>$E_{\text{eff}}/p$</th>
<th>Literature$^{[19]}$ (DC)</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td></td>
<td>$\mu$m</td>
<td></td>
<td></td>
<td>$B$</td>
</tr>
<tr>
<td>70</td>
<td>Ne</td>
<td>$67.2 \pm 4.3$</td>
<td>$0.92 \pm 0.03$</td>
<td>$110–200$</td>
<td>$750$</td>
</tr>
<tr>
<td>1800</td>
<td>He</td>
<td>$32.7 \pm 0.6^{(a)}$</td>
<td>$0.56 \pm 0.04^{(a)}$</td>
<td>$10–50^{(a)}$</td>
<td>$260$</td>
</tr>
<tr>
<td>70</td>
<td>He</td>
<td>$157.3 \pm 2.3$</td>
<td>$1.28 \pm 0.01$</td>
<td>$170–280$</td>
<td>$260$</td>
</tr>
<tr>
<td>70</td>
<td>Ar</td>
<td>$661.6 \pm 14$</td>
<td>$2.15 \pm 0.03$</td>
<td>$370–700$</td>
<td>$1350$</td>
</tr>
<tr>
<td>70</td>
<td>Ar</td>
<td>$1356 \pm 41$</td>
<td>$3.14 \pm 0.04$</td>
<td>$700–1840$</td>
<td>$1350$</td>
</tr>
<tr>
<td>70</td>
<td>N$_2$</td>
<td>$2378 \pm 52$</td>
<td>$3.28 \pm 0.04$</td>
<td>$1020–2820$</td>
<td>$1350$</td>
</tr>
<tr>
<td>25</td>
<td>Ar</td>
<td>$1407 \pm 35$</td>
<td>$3.20 \pm 0.03$</td>
<td>$750–1770$</td>
<td>$1350$</td>
</tr>
<tr>
<td>25</td>
<td>N$_2$</td>
<td>$2611 \pm 67$</td>
<td>$3.51 \pm 0.03$</td>
<td>$1490–3140$</td>
<td>$2560$</td>
</tr>
</tbody>
</table>

$^{(a)}$ $B$ and $C$ calculated from literature data.$^{[7]}$
seen in Figure 4, in this pressure range the ion oscillation amplitudes of both gases exceeded not only \( d/2 \) but also \( d \). Thus, the ignition behavior should again be dominated by the DC Townsend breakdown regime. With decreasing pressure, an increasing contribution of the field electron emission additionally lowers the breakdown voltages (significantly only in He). Thus, in the case of He, the voltages measured at low pressures are lower than the expected values given by the Paschen curves fitted at high pressures.

This reason can explain the additional decrease of the breakdown voltage, but not the special pressure dependent behavior shown in this pressure range. The experimental observation of the spatial distribution of the discharge helps with understanding the experimental data. At the breakdown the complete electrode surface is covered with a darker diffuse plasma compared to the intense plasma generated only at the gaps between the electrodes at high pressures. Thus, higher breakdown distances are favored to the shortest electrode gap width of 70 \( \mu \)m. Figure 6 shows that this effect is not only observed with \( d = 70 \mu \)m but also with \( d = 25 \mu \)m. This is consistent with the observation of additional parasite discharges at pressures lower than 40 kPa, which ignite independently of the MSE discharges within distances of several millimeters inside the chamber.

At pressures higher than 35 kPa, the parasite discharges have much higher breakdown voltages than the MSE discharges. The MSE driven discharges of Ne and He at pressures lower than 40 kPa represent the left hand branches of the Paschen curves near the minimum with higher effective \( d \) values, \( d_{\text{eff}} \) (see Figure 7). Therefore, the parasite discharges must represent the right-hand branches of the Paschen curves at high \( p \cdot d \) values (shown in Figure 7). In Ne, it was possible to estimate \( d_{\text{eff}} \), since with \( d_{\text{eff}} > d \) the ion oscillation amplitudes \( z_0 \) should not exceed \( d_{\text{eff}}/2 \), resulting in the high frequency regime dominating the breakdown mechanism. Thus, it is a good approximation to use the fitted constants \( B \) and \( C \) of Table 1. Table 2 summarizes the estimated \( d_{\text{eff}} \) values calculated with Equation (3). The solutions \( p \cdot d \) are shown in Figure 7. The 1st solution represents the MSE discharges with \( d_{\text{eff}} \) and the 2nd solution the parasite discharges with \( d_{\text{eff}} \) equal to the physical shortest distances between the conductors inside the vacuum chamber excluding the MSE array. As expected, with increasing pressure \( d_{\text{eff}} \) decreases, but the condition \( d_{\text{eff}}/2 > z_0 \) is always fulfilled (see Figure 4). At pressures higher than 35 kPa, \( d_{\text{eff}} \) becomes equal to \( d \) (70 \( \mu \)m).

Then, field electron emission dominates the breakdown mechanism (see above). In Ne at a pressure above 30 kPa, parasite discharges are no longer observed, because \( d_{\text{eff}} \) is smaller than the smallest electrode distance outside the MSE system, resulting in higher breakdown voltages (see above).

Since in He the effective \( d \) values were unknown, it was not possible to run a new fit with the Paschen formula, which would result in Paschen curves with considerably lower breakdown voltages than the fitted Paschen curves shown in Figure 5.

With \( d = 25 \mu \)m the ion oscillation amplitudes of all gases exceed not only \( d/2 \) but also \( d \). Thus, the ignition mechanism is dominated by the DC Townsend breakdown regime, which was confirmed by the Paschen fitted constants, \( B \), of Ar and \( N_2 \) (see Table 1). However, analogous to the 70 \( \mu \)m prototype, in Ne and He field electron emission dominates the breakdown mechanism at pressures higher than 40 kPa.\(^{[22]}\)

Figure 8 compares the RF breakdown voltages of Ar with the DC Paschen curve.\(^{[19]}\) Two effects can be observed. With the decrease of \( d \) to 25 \( \mu \)m the breakdown voltage is lowered, and with \( d = 70 \mu \)m at high pressures the Ar breakdown voltages are higher than the DC breakdown voltages. In Table 3 the estimated experimental secondary electron emission coefficients \( \gamma \) of all gases calculated with Equation (4) are summarized and compared with DC \( \gamma \) and \( \gamma_1 \) (electron emission by ion bombardment of the cathode).
values. A higher contribution of $\gamma_i$ to the ignition, resulting in the lowering of the breakdown voltage, can be excluded, since the calculated ion kinetic energies of Ar have almost identical values at the same $p \cdot d$ values for both electrode distances. Additionally, $\gamma_i$ of Ar is almost independent of the ion kinetic energies in the range of 5 eV to 500 eV. An increase in the contribution of field electron emission is responsible for this effect, because the ignition electric field strengths more than double. This effect is quantified by an increase in the experimental $\gamma$ value.

The estimated experimental $\gamma$ values of $d = 70$ µm confirm the present results, the $\gamma$ values of Ne and Ar at high pressures being very low compared to the DC value. Thus, the high frequency mechanism dominates. This result can also explain the fact that at high pressures the Ar breakdown voltages are even higher than the DC breakdown voltages (see Figure 8). The lower $B$ value of Ar (662 V · kPa$^{-1}$ · cm$^{-1}$) cannot compensate for the strong decrease in the $\gamma$ value. A higher frequency than 13.56 MHz should result in lower breakdown voltages for Ar (see He for comparison).

In order to determine the electron density, $n_e$, of the RF discharge the voltage-current characteristics were measured in He. Figure 9 shows the voltage-current characteristic of a 100 kPa He RF discharge generated with an MSE array ($d = 70$ µm). The characteristic is similar to the RF discharge characteristics observed by Park et al. (see above). Park et al. used a capacitor consisting of two planar square electrodes with an electrode gap width varying from 1 600 µm to 3 200 µm. Since our RF generator was power controlled with steps of 1 W, only five data points were gained before breakdown ($P_{gen} = 5$ W). Thus, no significant voltage drop is observed at breakdown due to the coarse steps. On the other hand, in N$_2$, a voltage drop of several 10 V is observed. The voltage-current characteristic of N$_2$ is characteristic for a glow discharge and is very similar to the characteristic of a low pressure DC discharge. For both gases the operational range is the normal glow range including the subnormal glow range showing characteristic hysteresis behavior. In He with $P_{gen}$ higher than 7 W, the plasma starts to cover the entire electrode system and the voltage across the discharge (about 150 V) is almost independent of the measured plasma current $I_p$ over several orders of magnitude, which is characteristic for the normal glow range.

The electron density of the RF glow discharge ($P_{gen} = 25$ W, see Figure 9) was estimated with a simple model used

### Table 2

<table>
<thead>
<tr>
<th>$p$ (kPa)</th>
<th>$U_{IP}$ (V)</th>
<th>$1^{st}$ solution $p \cdot d$ (kPa · cm)</th>
<th>$d_{eff}$ (MSE) (µm)</th>
<th>$2^{nd}$ solution $p \cdot d$ (kPa · cm)</th>
<th>$d_{eff}$ (parasite discharges) (µm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>10</td>
<td>80.73</td>
<td>0.730</td>
<td>730</td>
<td>1.843</td>
<td>1.843</td>
</tr>
<tr>
<td>15</td>
<td>86.83</td>
<td>0.665</td>
<td>443</td>
<td>2.226</td>
<td>1.484</td>
</tr>
<tr>
<td>20</td>
<td>94.37</td>
<td>0.617</td>
<td>308</td>
<td>2.680</td>
<td>1.340</td>
</tr>
<tr>
<td>25</td>
<td>97.30</td>
<td>0.603</td>
<td>241</td>
<td>2.855</td>
<td>1.142</td>
</tr>
<tr>
<td>30</td>
<td>99.43</td>
<td>0.594</td>
<td>198</td>
<td>2.982</td>
<td>994</td>
</tr>
<tr>
<td>35</td>
<td>101.63</td>
<td>0.585</td>
<td>167</td>
<td>$^a$</td>
<td>$^a$</td>
</tr>
</tbody>
</table>

$^a$ $U_{IP}$ (parasite discharge) is significantly higher than $U_{IP}$ (MSE, $d = 70$ and 25 µm).

### Table 3

<table>
<thead>
<tr>
<th>$d$ (µm)</th>
<th>Gas</th>
<th>$A$; literature$^{[19]}$ (kPa$^{-1}$ · cm$^{-1}$)</th>
<th>$C$; experiment (RF)</th>
<th>$\gamma$</th>
<th>$\gamma_i$ ($E_{kin}$ range); literature$^{[23]}$ (DC)</th>
</tr>
</thead>
<tbody>
<tr>
<td>70</td>
<td>Ne</td>
<td>30.0</td>
<td>0.92 ± 0.03</td>
<td>6.63 $\times 10^{-6}$</td>
<td>0.12–0.14 (5–90 eV)</td>
</tr>
<tr>
<td>1 800</td>
<td>He</td>
<td>22.5</td>
<td>0.56 ± 0.04$^a$</td>
<td>2.71 $\times 10^{-6}$</td>
<td>ca. 0.17 (5–90 eV)</td>
</tr>
<tr>
<td>70</td>
<td>He</td>
<td>22.5</td>
<td>1.28 ± 0.01</td>
<td>1.95 $\times 10^{-3}$</td>
<td>3.4 $\times 10^{-2}$–3.5 $\times 10^{-2}$ (5–500 eV)</td>
</tr>
<tr>
<td>70</td>
<td>Ar</td>
<td>90.0</td>
<td>2.15 ± 0.03</td>
<td>2.88 $\times 10^{-5}$</td>
<td>4.4 $\times 10^{-2}$b)</td>
</tr>
<tr>
<td>70</td>
<td>Ar</td>
<td>90.0</td>
<td>3.14 ± 0.04</td>
<td>2.10 $\times 10^{-2}$</td>
<td>See above</td>
</tr>
<tr>
<td>70</td>
<td>N$_2$</td>
<td>90.0</td>
<td>3.28 ± 0.04</td>
<td>3.53 $\times 10^{-2}$</td>
<td>4.4 $\times 10^{-2}$b)</td>
</tr>
<tr>
<td>25</td>
<td>Ar</td>
<td>90.0</td>
<td>3.20 ± 0.03</td>
<td>2.64 $\times 10^{-2}$</td>
<td>4.4 $\times 10^{-2}$b)</td>
</tr>
<tr>
<td>25</td>
<td>N$_2$</td>
<td>90.0</td>
<td>3.51 ± 0.03</td>
<td>7.33 $\times 10^{-2}$</td>
<td>See above</td>
</tr>
</tbody>
</table>

$^a$ $C$ and $\gamma$ calculated from literature data$^{[7]}$

$^b$ $\gamma$ calculated from literature data$^{[19]}$
by Park et al., where \( n_e \) was calculated according to:

\[
I_p = -n_e \cdot e \cdot \mu_e \cdot E
\]  

where \( A_p \) is the active plasma area and \( \mu_e = 0.107 \text{ m}^2 \cdot \text{V}^{-1} \cdot \text{s}^{-1} \) is the electron mobility for He [24–26]. Park et al. measured the sheath thickness of their system with optical emission spectroscopy gaining the thickness of the plasma bulk region in order to estimate the voltage and the electric field strength \( E \) across the bulk region [24]. They measured sheath thicknesses of 280 \( \mu \text{m} \) to 350 \( \mu \text{m} \) \((p = 80 \text{ kPa})\), dependent on input power, but independent of \( d \). The sheath thickness of Park et al. was at least four times larger than our MSE electrode gap width \( d = 70 \mu \text{m} \). Thus, conventional methods to obtain \( E \) do not apply to MSE systems. Additionally, the problem of describing how the electric field penetrates the plasma has not yet been solved [27]. In a glow discharge the degree of ionization, \( x \), is very low (see Table 4) and, at high pressures the sheath is collisional. Thus, we estimated the effective electric field strength \( E \) by dividing the overall field strength by a factor \( x \), the measured and pressure dependent dielectric constant of the medium. This effective field strength is probably higher than the actual field strength across the bulk region providing a minimal value of \( n_e \) (see Equation (5)). Table 4 summarizes all the estimated values. The degree of ionization \((x \approx 10^{-8})\) as well as the electron density \((n_e \approx 2 \times 10^{17} \text{ electrons} \cdot \text{m}^{-3})\) are characteristic for a glow discharge.

With pressures of 40 kPa to 60 kPa, the degree of ionization, \( x \), is independent of pressure, because in this pressure range the breakdown mechanism is dominated by field electron emission (see above). At a pressure of 70 kPa, the transition of the breakdown mechanism causes a decrease of \( x \). On the other hand, in the Paschen minimum (at pressures higher than 80 kPa) the breakdown voltage decreases (see Figure 3), which partially compensates the decrease in \( x \) resulting in a minimum of \( x \) at 70 kPa.

With \( n_e \) it is possible to estimate the Debye shielding distance, \( \lambda_D \), representing the minimum sheath thickness [18]. \( \lambda_D \) is calculated according to:

\[
\lambda_D = \sqrt{\frac{\varepsilon_0 \cdot k \cdot T_e}{e^2 \cdot n_e}}
\]

where \( \varepsilon_0 \) is the permittivity of a vacuum, \( k \) is the Boltzmann constant and \( T_e \) is the electron temperature. The MSE
plasma source generates electrons with kinetic energies of more than 20 eV.\cite{14} It is not possible to measure an electron energy distribution function with a conventional Langmuir probe. The smallest probe size of about 10 µm (realized by means of modern micro machining techniques) is still of the same magnitude as the electrode gap width. Although the experimental realization itself is an interesting challenge, the probe would disturb the measurement results by influencing the plasma parameters, because the ratio of plasma volume to probe surface is too small. Additionally, the special ratio of $\lambda_D$, $r_{\text{probe}}$ and the mean free path length $\lambda$ would necessitate developing a new model for data analysis.\cite{25}

Thus, in Table 4 we have summarized the $\lambda_D$ values for three different $T_e$ in each case. The estimated values of $\lambda_D$ (with $T_e = 5$ eV) are too high for $\lambda_D$ to represent the minimum sheath thickness. The actual electron densities are probably higher (see above) resulting in smaller $\lambda_D$ values. At a pressure of 100 kPa, $n_e \approx 10^{18}$ electrons $\cdot$ m$^{-3}$ yields $\lambda_D = 17$ µm ($T_e = 5$ eV) resulting in a 36 µm thick plasma bulk region for $d = 70$ µm. An electron density $n_e$ of $10^{18}$ electrons $\cdot$ m$^{-3}$ is high, but still characteristic for a glow discharge and was confirmed by simulations done at atmospheric pressure in He.\cite{18,28} $\lambda_D$ is more than one order of magnitude higher than $\lambda$ and of the same magnitude as the thickness of the bulk plasma, as well as the electrode gap width $d$. These ratios are very different from conventional DC or RF systems. $\lambda_D$ increases with decreasing pressure. At pressures below 40 kPa $\lambda_D$ exceeds $d$, but not $d_{\text{eff}}$ (see Table 2 for comparison), increasing the complexity of the system. In order to discuss the role of $\lambda_D$ in stabilizing the plasma against sparking or the influence of $\lambda_D$ on other effects, a new model needed to be developed for our system. With $P_{\text{gen}}$ up to 40 W in He, no sparking is observed. Additionally, it has to be considered that the sheath will expand and contract during the oscillating electric field.\cite{27}

In the future, we intend to measure the sheath thickness directly with optical emission spectroscopy in order to confirm the estimated values of $\lambda_D$. With additional experiments it will be possible to develop a comprehensive model providing acceptable quantitative predictions.

### Applications

With the MSE array as a plasma source incorporated into a micro-reactor, the decomposition of the greenhouse gas CF$_4$ was performed with rates of over 90% at a pressure of 10 kPa in He and N$_2$. At atmospheric pressure, the abatement rate was still over 70%.\cite{15,28} Additionally, the decomposition of NO in 100 kPa He has been investigated, where an abatement rate of 70% was achieved.\cite{15,29}

The MSE plasma source generates electrons with high kinetic energies (see above), fluorescent excited atoms and ions.\cite{14} These species have shown their applicability as sterilizing agents for resistant spores at atmospheric pressure.\cite{30} In sterilization experiments, the thermo-resistant spores of the vegetative bacteria Bacillus cereus and the UV-resistant spores of the fungus Aspergillus niger were deactivated in He and Ar. The setup consisted of the MSE plasma source coplanarly arranged opposite an inoculated (10$^6$ spores of each microorganism in 50 µL spore-solution) substrate (Si, Cu or different plastic films). The substrate was biased with various potentials to accelerate the reactive plasma species towards the substrate. After the plasma exposition, the substrate was pressed on the spore specific medium to detect viable spores. Optical emission spectroscopy proved the presumption that accelerated electrons and ions are the dominating sterilizing agents, because in the sterilizing UV range below 300 nm no emission lines were detected.\cite{31}

### Conclusion

With the MSE array, an alternative atmospheric pressure plasma source has been identified with many applications, such as in plasma chemistry (decomposition of waste gases like CF$_4$) and the sterilization of food packaging materials.

The MSE driven radio frequency discharges showed special behavior, which differed from conventional high frequency gas discharges. Due to the very small electrode gap width (25 µm to 70 µm) the behavior of the charged particles in the RF field could be described with the DC Townsend breakdown theory. Partially, dependent on pressure range and gas, the breakdown mechanism was dominated by field electron emission or the high frequency regime. The voltage-current characteristic and electron density of the MSE plasma in He at atmospheric pressure were characteristic of a glow discharge. The MSE system was very complex and could not be described quantitatively with a simple model derived from other RF or DC model systems. Additional experiments are necessary in order to develop a model which will provide acceptable quantitative predictions. Nevertheless, with the knowledge gained it is possible to design MSE arrays optimized for different pressure ranges and gases given by the application.

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